



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuo USHIDA et al.

Group Art Unit: 2851

Application No.: 09/320,472

Examiner: A. Mathews

Filed: May 25, 1999

Docket No.: 110197.98

For: PROJECTION EXPOSURE APPARATUS

STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Response to Quayle Action was filed for this application on **December 4, 2001**. In addition, the PTO database PAIR indicates that a Notice of Allowability was issued (but not yet mailed) by the Examiner on **May 1, 2002**. The PAIR database also indicates that this matter has been located with the SPRE of Tech Center 2800 since August 16, 2002.

Applicants request the Patent Office to mail the Notice of Allowance and Notice of Allowability as soon as possible as it has been nearly two years since Applicant satisfied the Quayle Action. The appropriate Patent Office official is invited to contact Applicants' undersigned attorney at the telephone number listed below if there are any questions.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC/ccs

Date: September 4, 2003

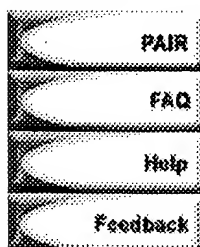
OLIFF & BERRIDGE, PLC
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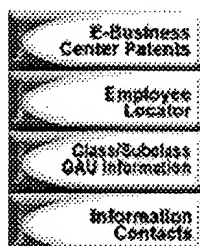
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PATENT APPLICATION INFORMATION RETRIEVAL



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Search results for application number: 09/320,472			
Application Number:	09/320,472	Customer Number:	25944
Filing or 371(c) Date:	05-25-1999	Status:	Allowed – Notice of Allowance Not Yet Made
Application Type:	Re-issue	Status Date:	05-01-2002
Examiner Name:	MATHEWS, ALAN A	Location:	TC-2800 SPRE, CP4-6
Group Art Unit:	2851	Location Date:	08-16-2002
Confirmation Number:	4765	Earliest Publication No:	
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Class/ Sub-Class:	355/053	Patent Number:	
First Named Inventor:	KAZUO USHIDA, TOKYO, (JP)	Issue Date of Patent:	
Title Of Invention: PROJECTION EXPOSURE APPARATUS			

[Foreign Priority](#)
[Continuity Data](#)
[Publication Review](#)

File Contents History

Number	Date	Contents Description
26	05-01-2002	Notice of Allowance Data Verification Completed
25	05-01-2002	Notice of Allowability
24	02-27-2002	Date Forwarded to Examiner
23	12-04-2001	Response after Ex Parte Quayle Action
22	11-19-2001	Oath or Declaration Filed (Including Supplemental)
21	11-20-2001	Mail Ex Parte Quayle Action (PTOL - 326)
20	11-19-2001	Ex Parte Quayle Action
19	11-13-2001	Date Forwarded to Examiner
18	11-09-2001	Supplemental Response
17	11-09-2001	Oath or Declaration Filed (Including Supplemental)
16	09-13-2001	Date Forwarded to Examiner
15	09-04-2001	Response after Non-Final Action
14	09-04-2001	Request for Extension of Time - Granted
13	09-04-2001	Information Disclosure Statement (IDS) Filed
12	08-31-2001	Examiner Interview Summary Record (PTOL - 413)
11	08-31-2001	Change in Power of Attorney (May Include Associate POA)
10	08-31-2001	Correspondence Address Change
9	08-31-2001	Change in Power of Attorney (May Include Associate POA)
8	04-04-2001	Mail Non-Final Rejection